

1                   **CORNER CUBE CHEMICAL-BIOLOGICAL AGENT SENSOR**

2                   **Background**

3                   The ensuing description relates generally to sensing systems for detecting environmental  
4 conditions.

5                   **Summary**

6                   A sensing system comprises a corner-cube reflector that has three reflective surfaces  
7 wherein at least one of the reflective surfaces is a surface of a bimaterial cantilever. The  
8 reflective surface of the bimaterial cantilever undergoes a change between a substantially planar  
9 shape and a curved shape upon direct exposure to an agent of interest. Such a change is  
10 perceived by a suitable detector.

11                  Other objects, advantages and new features will become apparent from the following  
12 detailed description when considered in conjunction with the accompanied drawings.

13                   **Brief Description of the Drawings**

14                  FIG. 1 illustrates a prior art corner cube reflector.

15                  FIG. 2 is a representative view of a sensor according to the description herein.

16                  FIG. 3 is a representative view of another sensor according to the description herein.

17                  FIG. 4 depicts a utilization of a sensor according to the description herein.

18                   **Description**

19                  Referring to FIG.1, a prior art corner cube reflector 10 is illustrated. Reflector 10 is

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1 shown to include three planar reflective surfaces 12, 14 and 16 that in this figure are arranged to  
2 be mutually orthogonal and that cumulatively form a right-angle concave mirror.

3 Such corner cube reflectors may, for example, be fabricated via the emerging technology  
4 known as MEMS (Micro Electro Mechanical Systems). The term MEMS broadly encompasses  
5 many different kinds of devices fabricated on the micron scale, such as sensors, actuators, and  
6 instruments. These devices are usually fabricated with integrated circuit technology on a silicon  
7 substrate. Such MEMS technology allows the fabrication of microsensors that are very small in  
8 size and that are easily transitioned into standard Integrated Circuit (IC) technology facilitates  
9 manufacturing.

10 Referring again to FIG. 1, it is well-known that a light ray 18 incident upon the corner  
11 cube reflector from direction A will result in a reflected-back ray 20 from direction -A, i.e.  
12 toward light source 22. This is the case when the light reflects off the three plano-reflective  
13 surfaces of the corner cube reflector. See for example, Scholl, "Ray Trace Through a Corner-  
14 Cube Reflector With Complex Reflection Coefficients", Journal of the Optical Society of  
15 America A, Vol. 12, No. 7, pp. 1589-1592 (1995).

16 Microcantilevers, such as those used in atomic force microscopy, are known to undergo  
17 bending due to forces involved in molecular adsorption. Adsorption induced forces can be so  
18 large that on a clean surface they can rearrange the lattice locations of surface and subsurface  
19 atoms, producing surface reconstructions and relaxations. An analogous transduction process is  
20 found in biology, where the interaction of membrane molecules modifies the lateral tension of a  
21 lipid bilayer. The resulting curvature of the membrane is responsible for mechanically triggering

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1 membrane protein function. See Zhiyu Hu, T. Thundat, and R. J. Warmack from Oak Ridge  
2 National Laboratory reported their "Investigation of adsorption and absorption-induced stresses  
3 using microcantilever sensors" in Journal of Applied Physics, Vol 90, Number 1. See also J.  
4 Fritz, MK Baller and HP Lang titled "Translating biomolecular recognition into nanomechanics",  
5 Science; Volume 288, Issue 5464, Pg. 316-318.

6 Specialized coatings, such as polymer coatings, may be added to the microcantilevers to  
7 react to specific agents of interest. Such coatings permit selected chemical/biological adsorption  
8 or absorption to take place at the cantilever. See the references by J. Fritz, MK Baller and HP  
9 Lang titled "Translating biomolecular recognition into nanomechanics", Science; Volume 288,  
10 Issue 5464, Pg. 316-318.

11 Referring now to FIG. 2, a bimaterial cantilever 24 is made part of a corner cube reflector  
12 26 having reflective surfaces 28, 30 and 32. Reflector 26 as shown in FIG. 2 is identified herein  
13 as being in a first sensing condition characterized by reflective surface 32 of bimaterial cantilever  
14 24 being substantially planar. When reflective surface 32 is substantially planar, the three  
15 reflecting surfaces 28, 30 and 32 of the reflector are mutually orthogonal as shown. Though  
16 reflector 26 is illustrated to include a single bimaterial cantilever, two or three such cantilevers  
17 may be used. Electromagnetic radiation 34, such as thermal, infrared, light or other, is projected  
18 from source 36 and is received in a first electromagnetic radiation state 38 by a detector 40. The  
19 first state of the electromagnetic radiation corresponds to reflected radiation when reflector 26 is  
20 in the first sensing condition as described above and as shown in FIG. 2.

21 Cantilever 24 may be comprised of a variety of material, examples of which can be

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1 found, for example, in the atomic force microscopy field. This field is known to employ  
2 cantilevers having a base of Si or Si<sub>3</sub>N<sub>4</sub> and a thin reflective surface of either gold or palladium.

3 Referring now to FIG. 3, another embodiment is shown wherein an agent sensitive  
4 coating 42 is suitably disposed on bimaterial cantilever 24. When positioned as shown in FIG. 3,  
5 such a coating is selected to be thin enough (suitable transparent) so that the reflectivity of the  
6 underlying material is not obstructed or is selected to be reflective itself. Such a coating, for  
7 example a polymer coating, is chosen to selectively bond to an agent of interest, such as a  
8 chemical or biological species.

9 Referring now to FIG. 4, a second sensing condition of reflector 26 is shown wherein  
10 bimaterial cantilever 24 has deflected as a function of molecular interactions. The cantilever  
11 transforms from a substantially planar shape, as shown in FIG. 2, to a curved shape upon  
12 encountering an agent of interest. Reflective surface 32 will likewise undertake this curved  
13 shape as well as any agent sensitive coating 42 placed upon the reflective surface, whether the  
14 coating itself is also reflective or is transparent as indicated above. When cantilever 24 deflects,  
15 it disrupts the alignment of the corner cube reflector. Electromagnetic energy 34 from source 36  
16 takes on a second state 38' upon being reflected from the reflector in the condition shown and is  
17 then received at detector 40. In this process, the second state of the electromagnetic energy (38')  
18 has experienced a shift from the first state of the electromagnetic energy (38) as received at  
19 detector 40. The change in the received electromagnetic energy, due to the deflection of  
20 cantilever 24, may be measured at detector 40 in terms of intensity, angular direction or phase  
21 change, and is equated with a change in the presence of an agent of interest, such as a chemical or

1 biological agent species.

2 In the figures, for simplicity, the associated substrate on which the cantilever is formed is  
3 not shown. This substrate, however, may contain control circuitry, alternate sensors, etc. as  
4 desired for specific applications.

5 The method of fabricating the corner cube chemical-biological agent sensor is analogous  
6 to the steps carried out in prior art MEMS corner cube fabrication, with the exception that one or  
7 more bimaterial cantilevers are used and that an optional agent sensitive coating is formed on the  
8 cantilever or cantilevers. It is suitable to form the coating prior to the assembly of the corner  
9 cube. Piezoelectric transducers, as practiced in the art, could be integrated to self-assemble the  
10 corner cube reflector.

11 The sensor described herein is miniaturizable, allows remote (non-contact) read-out,  
12 requires no electrical bias (power), and is immune to electromagnetic interference.

13 Though a sensor employing a corner cube retroreflector has been described, the concept  
14 of utilizing a bimaterial cantilever is considered extendable to other retroreflectors, such as a  
15 penta-prism.

16 Obviously, many modifications and variations are possible in light of the above  
17 description. It is therefore to be understood that within the scope of the claims the invention may  
18 be practiced otherwise than as has been specifically described.